

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent of:)
	:
Yoshiharu KATAOKA) Examiner: S. W. Smoot
	:
Application No.: 10/801,722) Group Art Unit: 2813
	:
Filed: March 17, 2004) Confirmation No.: 1892
	:
For: ALIGNMENT METHOD AND EXPOSURE) February 13, 2007
APPARATUS USING THE METHOD	:
)
U.S. Patent No. 7,098,046 B2	:
)
Issued: August 29, 2006	:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Attention: Certificate of Correction Branch

REQUEST FOR
CERTIFICATE OF CORRECTION
UNDER RULES 322 AND 323

Sir:

Patentee requests that a Certificate of Correction be issued by the Patent and Trademark Office due to errors which appear in the printed patent as a result of U.S. Patent and Trademark Office mistakes and a mistake of a minor nature which is not the fault of the U.S. Patent and Trademark Office.

The statutory fee of \$100.00 is being paid electronically. Any additional fee required by this paper may be charged to Deposit Account No. 06-1205.

Patentee's undersigned attorney may be reached in our Washington, D.C. Office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Steven E. Warner", is written over a horizontal line.

Attorney for Patentee

Steven E. Warner

Registration No. 33,326

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UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 7,098,046 B2

DATED : August 29, 2006

INVENTOR(S): Yoshiharu KATAOKA

Page 1 of 1

It is certified that errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

ON THE COVER PAGE:

In item “(57) **ABSTRACT**,” please cancel the current abstract and insert the following therefor:

-- An exposure method of exposing a substrate to a pattern in which a mark in each of a plurality of layers on the substrate is detected for alignment of the substrate. The method includes illuminating a mark in each of a plurality of layers on a substrate, detecting an image of the illuminated mark in each of the plurality of layers, and setting an illumination condition in the illuminating step for the mark in each of the plurality of layers. --

COLUMN 6:

Line 41, “as,” should read -- os, --.

COLUMN 7:

Line 49, “are” should read -- is --.

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FORM PTO 1050 (REV. 3.82)

PATENT NO. 7,098,046 B2

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